

## Electronic Acknowledgement Receipt

<b>EFS ID:</b>	3303459
<b>Application Number:</b>	10566170
<b>International Application Number:</b>	
<b>Confirmation Number:</b>	2513
<b>Title of Invention:</b>	SEMICONDUCTOR FILM MANUFACTURING METHOD AND SUBSTRATE MANUFACTURING METHOD
<b>First Named Inventor/Applicant Name:</b>	Yoshinobu Sekiguchi
<b>Customer Number:</b>	5514
<b>Filer:</b>	Damond Edward Vadnais
<b>Filer Authorized By:</b>	
<b>Attorney Docket Number:</b>	00862.109138.
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<b>Application Type:</b>	U.S. National Stage under 35 USC 371

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## File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Foreign Reference	TW_558743.pdf	3157069	no	93
			a508b6785c70fa3ac12a3c0419f2b419527c4d94		
Warnings:					
Information:					
2	NPL Documents	TW_Official_Action.pdf	848529	no	23
			f74dc06c2c7b6b0d57799276a2b9c36370ba55c9b		
Warnings:					
Information:					
3	Foreign Reference	TW_I284360.pdf	1912747	no	54
			e70c24735effb970203c7eb7d4aa541b332221f		
Warnings:					
Information:					
4	NPL Documents	Xiao_Intro_Semiconductor_Mfg_Tech_2001_p603.pdf	208079	no	2
			85769105229481060efbf1305c9ca23961b0cd69		
Warnings:					
Information:					
5	Information Disclosure Statement (IDS) Filed	IDS_00862_109138.pdf	784408	no	4
			33072553441d20ceaddf9e0b2a34e42a3d6e0c193a		
Warnings:					
Information:					
6	Fee Worksheet (PTO-06)	fee-info.pdf	8236	no	2
			72618ae94432ba9b9ba2039edc0b425d40c951a3		
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**New International Application Filed with the USPTO as a Receiving Office**

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